



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

MAR 17 2003

Applicant(s): Kobayashi, Kigaku

Serial No.: 10/060,569

Group Art Unit: 1763

Filed: January 29, 2002

Examiner: Goudreau, G.

Title: **METHOD OF FABRICATING A SEMICONDUCTOR DEVICE**

Attorney Docket No.: N230500C1

RESPONSE TO FINAL OFFICE ACTION

5 Assistant Commissioner for Patents
BOX AF
Washington, D.C. 20231

Dear Sir:

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The following is submitted in response to the Final Office Action dated January 13, 2003,
the two month Advisory Action Period ends March 13, 2003.

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Entry of the following amendments is respectfully requested.

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37 C.F.R. §1.8



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Patents, Washington, D.C. 20231.

Date of Deposit: March 12, 2003

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Typed/Printed Name: Darryl Walker

Signature: D. Walker